## Universida<sub>de</sub>Vigo

## Subject Guide 2015 / 2016

IDENTIFYIN	G DATA			
Metrologica	al Laser Applications			
Subject	Metrological Laser			
	Applications			
Code	001M117V01201			
Study	(*)Máster			
programme	Universitario en			
	Láser			
Descriptors	ECTS Credits	Choose	Year	Quadmester
<u></u>	6	Optional	1st	2nd
Teaching		• p		
language				
Department				
Coordinator	Vázquez Dorrío, José Benito			
Lecturers	Blanco García, Jesús			
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General	The subject [Metrological Applications of La	asers is an optional one, ge	eneralist and pr	actical whose essential
description	objective is to know the solutions that the t	technical laser offers in the i	d industrial incr	bootion. It intends to
	deepen in the theoretical and practical kno	wledge of the main optical t	echniques of m	easure in three areas of
	big current interest how field interferometr	v and evaluation of phase t	he inspection of	f surfaces and the TV-
	holography. These contents provide a wide	base of knowledges that all	ows the back a	cauisition of the
	necessary skills both theoretical and practi-	cal, in relation with the profe	essional perform	nance and focused the
	field of photonics and laser technologies.		·	
Competenc	ies			

Code	2
C4	Capacity for identification and description of optical laser sensors and actuators , including integrated sensors and optical fibers and their applications in various fields and recognition of commercial systems.
D3	Skill in interpersonal relationships.
D4	Capacity for independent learning, self-organization and self-scheduling of work, and to maintain continuous training in their field of work.

## Learning outcomes

Expected results from this subject	Training and Learning Results
Know the concepts, models and fundamental theories of optical metrology that allow the students a scientific interpretation of the process of measure and serve of base for back learnings more specific and/or technical.	C4
Comprise that optical metrology is a technical knowledge with limitations and subjected to review and continuous evolution, due to a process of technology-science interaction and tied to the characteristics and to the needs of the society in each historical moment.	D4
Propose and develop solutions of daily phenomena and problems, using the techniques of optical metrology.	
Apply the theoretical knowledges to the resolution of metrological problems developing suitable	C4
strategies.	D4
Use with autonomy characteristic strategies of the investigation and of the scientific procedures, within	C4
the scope of the optical metrology, to perform small investigations and, in general, explore situations or strange phenomena	D3

Contents	
Торіс	
Generalities	Introduction. General characteristics of the systems of optical measurement. The laser in metrology Measurable attributes by optical means. Ranking of the optical techniques of dimensional metrology.
Interferometric field techniques	Two-beam interferometers Multiple beam interferometers Applications. Automatic analysis of interferograms. Design of algorithms of displacement of phase.
Techniques of inspection of surfaces	Surface topography. Rugosity. Macrodefects. Needle perfilometers (stylus). Optica perfilometers. Parametric optical techniquesfot the measure of rugosity.
Optical techniques stop the industrial inspection of defects	Panorama of optical reflectometric techniques for industrial inspection. Practical case: inspection of cracks in tubes of heat interchangers by means of a reflectometric fibre sensor. Introduction to the techniques of inspection of defects by means of holographic interferometry and TV-holography. Description of TV holography: Geometry, temporary treatment, secondary fringes and evaluation of phase. Practical case: detection by means of TV-holography of ultrasonic wave propagation for the detection of cracks in metallic plates.

Planning			
	Class hours	Hours outside the	Total hours
		classroom	
Troubleshooting and / or exercises	10	0	10
Autonomous troubleshooting and / or exercises	0	100	100
Master Session	38	0	38
Multiple choice tests	2	0	2
*The information in the planning table is for guidar	nce only and does no	t take into account the hete	erogeneity of the students.

Methodologies	
	Description
Troubleshooting and / or exercises	The professor will resolve the exercises and problems that will serve of model stop those that the student will owe to resolve of autonomous way.
Autonomous troubleshooting and / or exercises	The student will resolve of autonomous way the problems and exercises proposed for the subject
Master Session	The professor will expose the main concepts of the subject with the support of the opportune teaching material available online.

Personalized attention	
Methodologies	Description
Autonomous troubleshooting and / or exercises	Voluntary tutorship. Help in the realization of the different tasks (individual or collective)

Assessment				
	Description	Qualification	Training a	nd Learning
			Re	sults
Autonomous troubleshooting and / or	Periodic delivery of collections of problems realized	50	C4	D3
exercises	of autonomous way.			D4
Multiple choice tests	Test with multiple options question	50	C4	D3
	· · · ·			D4

Other comments on the Evaluation

The evaluation tries to be continuous and realized through proposals of individual resolution and type test. Can be caught up

with maximum qualification carrying out these tasks. In the case of had not realized the continuous evaluation the students will be able to realize a final examination in the dates and place that appears in the web of the master: #http://master.laserphotonics.org/

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D. Malacara, **Optical Shop Testing**, John Wiley & amp; Sons, G. Cloud, **Optical Methods of Engineering Analysis**, Cambridge University Press,

P. Cielo, Optical Techniques for Industrial Inspection, Academic Press,

Recommendations